

Datasheet: MakroPorP1.5M1-230

Macro porous silicon lift-off membrane (305868-W06)

Etching

Pitch P: 1.5 μm trigonal

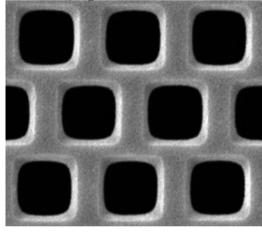
Pore length L: 234 μm Pore diameter D: 1 μm

Postprocessing

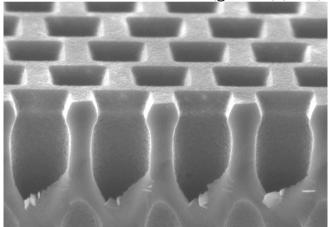
Membrane lift-off Laser dicing

Images

Front Top (generic) (SEM)



Front sideview + bottleneck (generic) (SEM)



Remarks

lifted backside (generic) (SEM)

- Lifted backsides are sensitive to mechanical handling.
 Abrasion of silicon nanotips is visible as brown "scratches" on the surface but have minor effect on the underlying pores. We suggest using vacuum tweezers on the front side. Depending on the thickness, <u>flat tips with small diameters are preferred instead of suction cup tips</u>, to minimize mechanical Stress.
- Please be aware: Thin membranes may flip due to electrostatic forces while opening or closing transport boxes!